DEC 2 8 2005

TO THE UNITED STATES PATENT AND TRADEMARK OFFICE

Filing Inver Assig Grou Exar Attor Cust	nt Application Serial No. g Date ntor gnee up Art Unit niner ney Docket No. omer No. the Atomic Layer Deposition Methods Comprising Layers		AuBrenda EMicron Tec	gust 18, 2003 D. Kraus et al. Chnology, Inc. 1762 Unknown MI22-2310 021567			
TO:	Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450						
STATUS INQUIRY							
1.	More than twenty-eight (28) months have passed since the filing of the above-identified patent application. No communication from an examiner has been received from the Patent and Trademark Office since that date.						
2.	Kindly advise the undersigned of the present status of this patent application, in particular, when the undersigned might reasonably expect to receive a first office action or allowance. A Status Inquiry Reply is provided as the second page hereof. Please complete and then fax said second page/reply to the facsimile number indicated thereon.						
n	ated: 12-27-05 By:	ã	and the				
Te Fa	elephone No.: (509) 624-4276 ax No.: (509) 838-3424 ustomer No.: 021567	We 601	rk S. Matkin, Reg. N Ils St. John P.S. I West First Avenue okane, WA 99201-3	, Suite 1300			
	CERTIFICATE OF MAILING/TRAM		•				
l hereb	y certify that, on the date shown below, this correspon	dence	is being:				
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STATUS INQUIRY REPLY

RE:	PATENT APPLICATION SERIAL NO. 10/643,680:							
			N OR ALLOWANCE IS EXPECTED	TO BE (Date)				
		IS AWAITING						
PLEA	ASE F	AX THIS REPLY TO:	Mark S. Matkin Wells St. John P.S.					